

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)

Application Number		10693004
Filing Date		2003-10-24
First Named Inventor	Galen C. Hunt	
Art Unit	2167	
Examiner Name	Nirav K. Khakhar	
Attorney Docket Number	MS1-1776US	

U.S.PATENTS

Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear
	1	5930798		1999-07-27	Lawler, ; et al.	
	2	6209099		2001-03-27	Saunders	
	3	6305015		2001-10-16	Akriche, ; et al.	
	4	6449650		2002-09-10	Westfall, ; et al.	
	5	6546553		2003-04-08	Hunt	
	6	6574195		2003-06-03	Roberts	
	7	6772333		2004-08-03	Brendel	
	8	6813778		2004-11-02	Poli, ; et al.	

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	9	6868062		2005-03-15	Yadav, ; et al.	
	10	6928482		2005-08-09	Ben Nun, ; et al.	
	11	6968550		2005-11-22	Branson, ; et al.	
	12	6968551		2005-11-22	Hediger, ; et al.	
	13	7043407		2006-05-09	Lynch, ; et al.	
	14	7103185		2006-09-05	Srivastava, ; et al.	
	15	7103874		2006-09-05	McCollum, ; et al.	
	16	7139999		2006-11-21	Bowman-Amuah	
	17	7155490		2006-12-26	Malmer, ; et al.	
	18	7181731		2007-02-20	Pace, ; et al.	
	19	7197418		2007-03-27	Fuller, III, ; et al.	

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	20	7315801		2008-01-01	Dowd, ; et al.	
	21	7403901		2008-07-22	Carley, ; et al.	
	22	7464147		2008-12-09	Fakhouri, ; et al.	

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	1	20010051937	A1	2001-12-13	ROSS, NIALI; et al.	
	2	20020009079	A1	2002-01-24	Jungck, Peder J.; et al.	
	3	20030028642	A1	2003-02-06	Agarwal, Vikas; et al.	
	4	20050021742	A1	2005-01-27	Yemini, Shaula Alexander; et al.	

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FOREIGN PATENT DOCUMENTS

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	1	Heinl, et al., "A Comprehensive Approach to Flexibility in Workflow Management Systems", WACC 1999, ACM, 1999, pp 79-88	<input type="checkbox"/>
	2	"Remote Operating System Installation", retrieved on 2-13-2009 at <<http://technet.microsoft.com/en-us/library/bb742501.aspx>>, Microsoft TechNet, September 9, 1999, pp 1-28	<input type="checkbox"/>

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